International **ICR** Rectifier REPETITIVE AVALANCHE AND dv/dt RATED HEXFET® TRANSISTOR

IRH7250 IRH8250 N CHANNEL MEGA HARD RAD

200Volt, 0.11Ω , MEGA RAD HARD HEXFET

International Rectifier's RAD HARD technology HEXFETs demonstrate excellent threshold voltage stability and breakdown voltage stability at total radiation doses as high as 1×10^6 Rads(Si). Under **identical** pre- and post-irradiation test conditions, International Rectifier's RAD HARD HEXFETs retain **identical** electrical specifications up to 1×10^5 Rads (Si) total dose. No compensation in gate drive circuitry is required. These devices are also capable of surviving transient ionization pulses as high as 1×10^{12} Rads (Si)/Sec, and return to normal operation within a few microseconds. Since the RAD HARD process utilizes International Rectifier's patented HEXFET technology, the user can expect the highest quality and reliability in the industry.

RAD HARD HEXFET transistors also feature all of the well-established advantages of MOSFETs, such as voltage control, very fast switching, ease of paralleling and temperature stability of the electrical parameters. They are well-suited for applications such as switching power supplies, motor controls, inverters, choppers, audio amplifiers and high-energy pulse circuits in space and weapons environments.

Absolute Maximum Ratings 0

Product Summary

Part Number	BVDSS	RDS(on)	ID
IRH7250	200V	0.11Ω	26A
IRH8250	200V	0.11Ω	26A

Features:

- Radiation Hardened up to 1 x 10⁶ Rads (Si)
- Single Event Burnout (SEB) Hardened
- Single Event Gate Rupture (SEGR) Hardened
- Gamma Dot (Flash X-Ray) Hardened
- Neutron Tolerant
- Identical Pre- and Post-Electrical Test Conditions
- Repetitive Avalanche Rating
- Dynamic dv/dt Rating
- Simple Drive Requirements
- Ease of Paralleling
- Hermetically Sealed

Pre-Irradiation

	nunigo 👳		
	Parameter	IRH7250, IRH8250	Units
ID @ VGS = 12V, TC = 25°C	Continuous Drain Current	26	
$I_D @ V_{GS} = 12V, T_C = 100^{\circ}C$	Continuous Drain Current	16	A
IDM	Pulsed Drain Current @	104	
P _D @ T _C = 25°C	Max. Power Dissipation	150	W
	Linear Derating Factor	1.2	W/°C
VGS	Gate-to-Source Voltage	±20	V
EAS	Single Pulse Avalanche Energy 3	500	mJ
IAR	Avalanche Current 2	26	A
EAR	Repetitive Avalanche Energy@	15	mJ
dv/dt	Peak Diode Recovery dv/dt ④	5.0	V/ns
TJ	Operating Junction	-55 to 150	
TSTG	Storage Temperature Range		°C
	Lead Temperature	300 (0.063 in. (1.6mm) from case for 10s)	
	Weight	11.5 (typical)	g

1

Electrical Characteristics	@ Tj = 25°C (Unless Otherwise Specified) ①
-----------------------------------	--------------------------------------------

	Parameter	Min	Тур	Max	Units	Test Conditions
5.4			тур	WIAA		
BVDSS	Drain-to-Source Breakdown Voltage	200			V	VGS = 0V, ID = 1.0mA
∆BV _{DSS} /∆TJ	Temperature Coefficient of Breakdown Voltage	_	0.27	-	V/°C	Reference to 25°C, $I_D = 1.0$ mA
RDS(on)	Static Drain-to-Source On-State	—	—	0.10	0	VGS = 12V, ID = 16A (5)
	Resistance	—	—	0.11	Ω	VGS = 12V, ID = 26A ⑤
VGS(th)	Gate Threshold Voltage	2.0	—	4.0	V	$V_{DS} = V_{GS}$, $I_{D} = 1.0 mA$
9fs	Forward Transconductance	8.0	—	—	S (ひ)	VDS > 15V, IDS = 16A ⑤
IDSS	Zero Gate Voltage Drain Current	_	—	25		VDS= 0.8 x Max Rating, VGS=0V
		—	—	250	μA	V _{DS} = 0.8 x Max Rating
						VGS = 0V, TJ = 125°C
IGSS	Gate-to-Source Leakage Forward	_	—	100		VGS = 20V
IGSS	Gate-to-Source Leakage Reverse		—	-100	nA	VGS = -20V
Qg	Total Gate Charge	_	—	170		VGS =12V, ID = 26A
Qgs	Gate-to-Source Charge	—	_	30	nC	V _{DS} = Max Rating x 0.5
Q _{gd}	Gate-to-Drain ('Miller') Charge	—	—	60		
td(on)	Turn-On Delay Time	_	—	33		VDD = 100V, ID = 26A,
tr	Rise Time	—	—	140		$R_{G} = 2.35\Omega$
^t d(off)	Turn-Off Delay Time	—	—	140	ns	
tf	Fall Time	—	—	140		
LD	Internal Drain Inductance		5.0	_	nH	Measured from drain lead, 6mm (0.25 in) from package to center inductances.on
LS	Internal Source Inductance		13	_	-	of die. Measured from source lead, 6mm (0.25 in) from package to source bonding pad.
Ciss	Input Capacitance	_	4700	—		$V_{GS} = 0V, V_{DS} = 25V$
C _{oss}	Output Capacitance		850	—	pF	f = 1.0MHz
C _{rss}	Reverse Transfer Capacitance	—	210	—		

Source-Drain Diode Ratings and Characteristics **①**

	Parameter	Min	Тур	Max	Units	Test Conditions
IS	Continuous Source Current (Body Diode)	—	-	26	Α	Modified MOSFET symbol
ISM	Pulse Source Current (Body Diode) 2		-	104		showing the integral reverse p-n junction rectifier.
VSD	Diode Forward Voltage	_	—	1.4	V	Tj = 25°C, IS = 26A, VGS = 0V (5)
trr	Reverse Recovery Time		—	820	ns	Tj = 25°C, IF = 26A, di/dt ≤ 100A/μs
QRR	Reverse Recovery Charge		—	12	μC	V _{DD} ≤ 50V ⑤
ton	Forward Turn-On Time Intrinsic turn-o	Intrinsic turn-on time is negligible. Turn-on speed is substantially controlled by LS + L				

Thermal Resistance

	Parameter	Min	Тур	Max	Units	Test Conditions
RthJC	Junction-to-Case	—	—	0.83		
R _{th} JA	Junction-to-Ambient	-	—	30	°C/W	
RthCS	Case-to-Sink	0.12	—	—		Typical socket mount

Radiation Performance of Rad Hard HEXFETs

International Rectifier Radiation Hardened HEXFETs are tested to verify their hardness capability. The hardness assurance program at International Rectifier comprises three radiation environments.

Every manufacturing lot is tested in a low dose rate (total dose) environment per MIL-STD-750, test method 1019 condition A. International Rectifier has imposed a standard gate condition of 12 volts per note 5 and a V_{DS} bias condition equal to 80% of the device rated voltage per note 6. Pre- and post- irradiation limits of the devices irradiated to 1 x 105 Rads (Si) are identical and are presented in Table 1, column 1, IRH7250. Post-irradiation limits of the devices irradiated to 1 x 10⁶ Rads (Si) are presented in Table

1, column 2, IRH8250. The values in Table 1 will be met for either of the two low dose rate test circuits that are used. Both pre- and post-irradiation performance are tested and specified using the same drive circuitry and test conditions in order to provide a direct comparison.

High dose rate testing may be done on a special request basis using a dose rate up to 1 x 10¹² Rads (Si)/Sec (See Table 2).

International Rectifier radiation hardened HEXFETs have been characterized in heavy ion Single Event Effects (SEE) environments. Single Event Effects characterization is shown in Table 3.

Table 1. L	Low Dose Rate 6 0	IRH	7250	IRH	3250		
	Parameter		Rads (Si)	1000K F	Rads (Si)	Units	Test Conditions
		Min	Max	Min	Max		
BV _{DSS}	Drain-to-Source Breakdown Voltage	200	_	200	_	V	$V_{GS} = 0V, I_{D} = 1.0mA$
VGS(th)	Gate Threshold Voltage	2.0	4.0	1.25	4.5		$V_{GS} = V_{DS}, I_D = 1.0 \text{mA}$
IGSS	Gate-to-Source Leakage Forward	—	100	—	100	nA	$V_{GS} = 20V$
I _{GSS}	Gate-to-Source Leakage Reverse	-	-100	—	-100		V _{GS} = -20 V
IDSS	Zero Gate Voltage Drain Current	-	25	—	50	μA	V _{DS} =0.8 x Max Rating, V _{GS} =0V
RDS(on)1	Static Drain-to-Source (5)	-	0.100	—	0.155	Ω	VGS = 12V, ID = 16A
	On-State Resistance One						
V _{SD}	Diode Forward Voltage (5)	—	1.4	_	1.4	V	$T_{C} = 25^{\circ}C$, $I_{S} = 26A$, $V_{GS} = 0V$

T-1.1. 4 1

Table 2. High Dose Rate 8

		10 ¹¹ Rads (Si)/sec 10 ¹² Rads (Si)/sec							
	Parameter	Min	Тур	Max	Min	Тур	Max	Units	Test Conditions
VDSS	Drain-to-Source Voltage	—	—	160	—	—	160	V	Applied drain-to-source voltage during
									gamma-dot
IPP		—	15	—	—	15	—	A	Peak radiation induced photo-current
di/dt		—	—	160	—	—	8.0	A/µsec	Rate of rise of photo-current
L1		1.0	—	—	20	—	—	μH	Circuit inductance required to limit di/dt

Table 3. Single Event Effects

lon	LET (Si) (MeV/mg/cm ²)	Fluence (ions/cm ²)	Range (μm)	V _{DS} Bias (∀)	V _{GS} Bias (∀)
Cu	28	3x 10⁵	43	180	-5

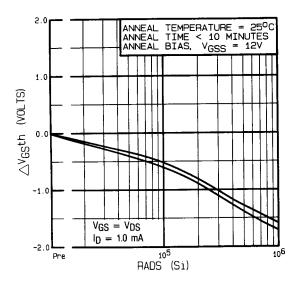


Fig 1. Typical Response of Gate Threshhold Voltage Vs. Total Dose Exposure

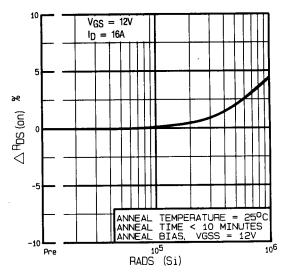
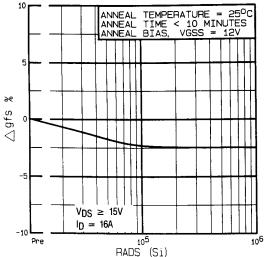
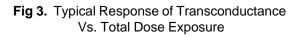
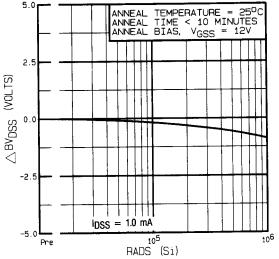
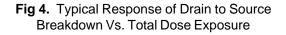


Fig 2. Typical Response of On-State Resistance Vs. Total Dose Exposure

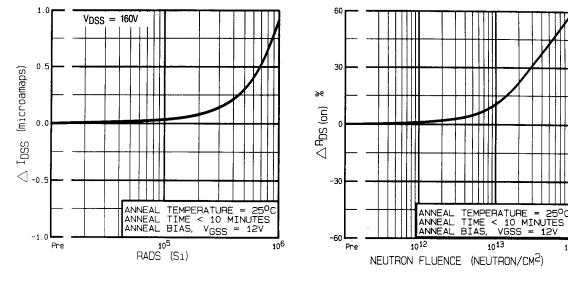


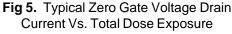


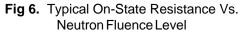




1014







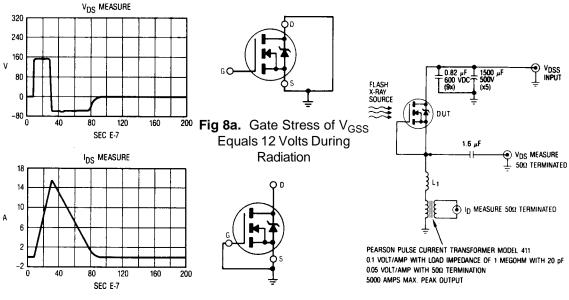
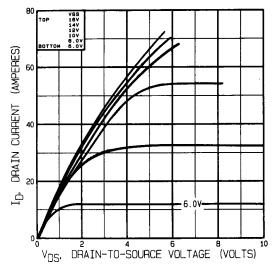
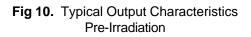


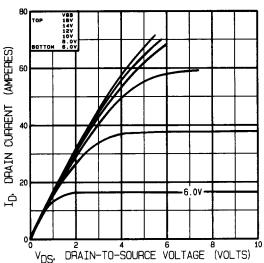
Fig 7. Typical Transient Response of Rad Hard HEXFET During 1x10¹² Rad (Si)/Sec Exposure Fig 8b. V_{DSS} Stress Equals 80% of B_{VDSS} During Radiation

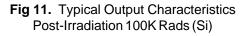
Fig 9. High Dose Rate (Gamma Dot) Test Circuit

Note: Bias Conditions during radiation: $V_{GS} = 12 \text{ Vdc}, V_{DS} = 0 \text{ Vdc}$









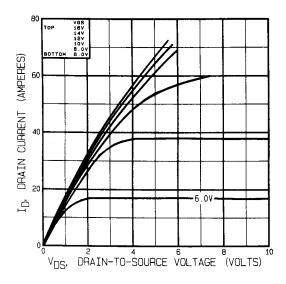


Fig 12. Typical Output Characteristics Post-Irradiation 300K Rads (Si)

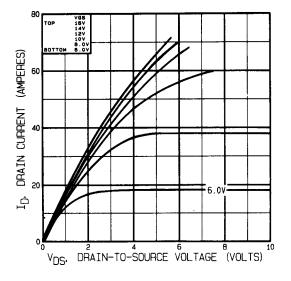
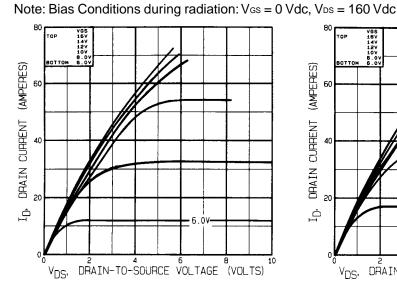
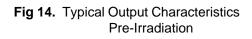
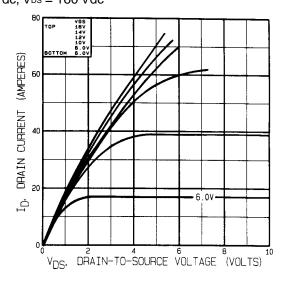
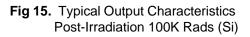


Fig 13. Typical Output Characteristics Post-Irradiation 1 Mega Rads(Si)









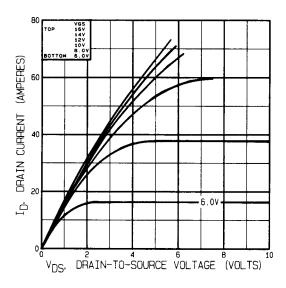
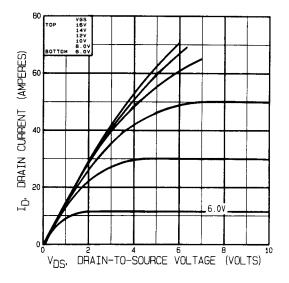
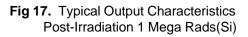


Fig 16. Typical Output Characteristics Post-Irradiation 300K Rads (Si)





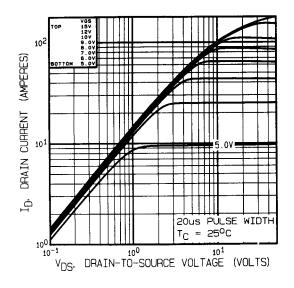


Fig 18. Typical Output Characteristics

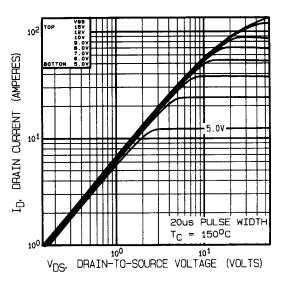


Fig 19. Typical Output Characteristics

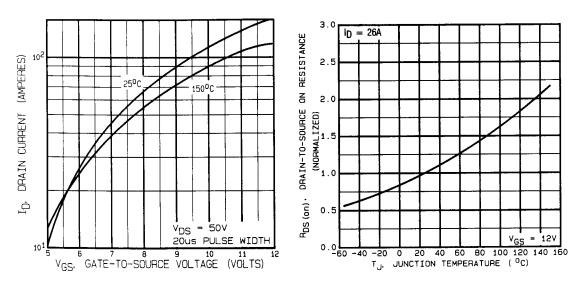
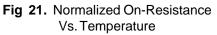
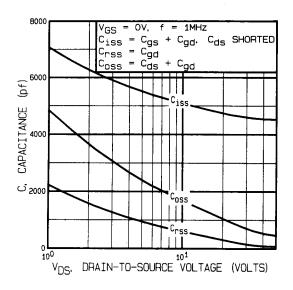
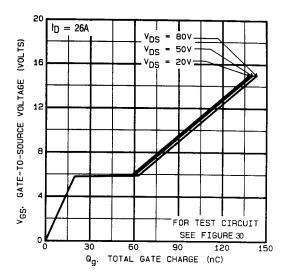


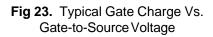
Fig 20. Typical Transfer Characteristics

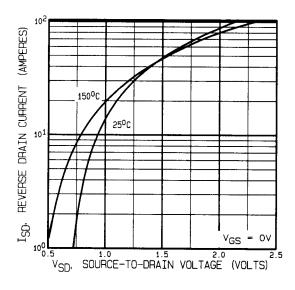


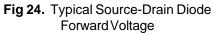


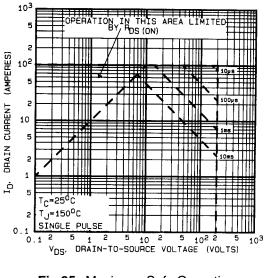


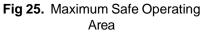


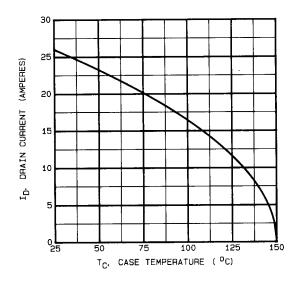




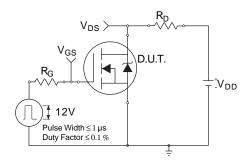


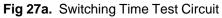












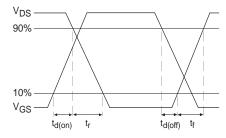
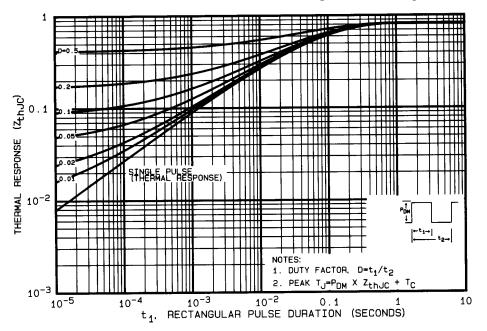
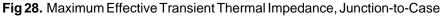


Fig 27b. Switching Time Waveforms





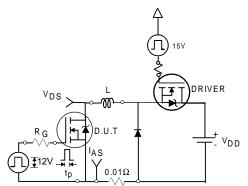


Fig 29a. Unclamped Inductive Test Circuit

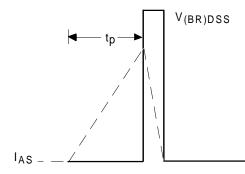


Fig 29b. Unclamped Inductive Waveforms

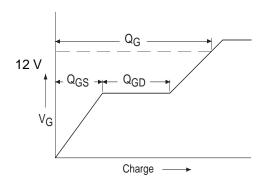


Fig30a. Basic Gate Charge Waveform

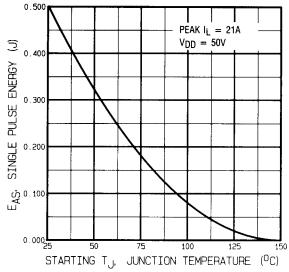


Fig 29c. Maximum Avalanche Energy Vs. Drain Current

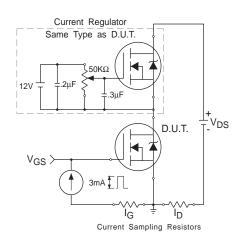
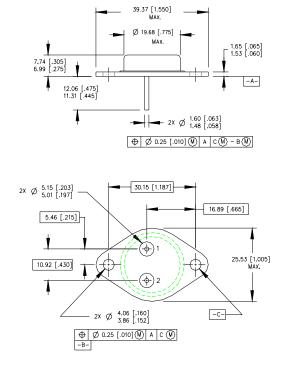


Fig 30b. Gate Charge Test Circuit

Pre-Irradiation

- ① See Figures 18 through 31 for pre-irradiation curves
- ② Repetitive Rating; Pulse width limited by maximum junction temperature. Refer to current HEXFET reliability report.
- ③ V_{DD = 25V}, Starting T_J = 25°C, Peak I_L = 26A,L=1.9mH, R_G=25Ω
- \bigcirc Pulse width \leq 300 μ s; Duty Cycle \leq 2%

- Total Dose Irradiation with V_{GS} Bias.
 12 volt V_{GS} applied and V_{DS} = 0 during irradiation per MIL-STD-750, method 1019, codition A.
- ⑦ Total Dose Irradiation with V_{DS} Bias. V_{DS} = 0.8 rated BV_{DSS} (pre-radiation) applied and V_{GS} = 0 during irradiation per MIL-STD-750, method 1019, condition A.
- ③ This test is performed using a flash x-ray source operated in the e-beam mode (energy ~2.5 MeV), 30 nsec pulse.
- ③ All Pre-Irradiation and Post-Irradiation test conditions are identical to facilitate direct comparison for circuit applications.



Case Outline and Dimensions — TO-204AE

PIN ASSIGNMENTS	
-----------------	--

1 - SOURCE

- 2 GATE
- 3 DRAIN (CASE)

NOTES:

- 1. DIMENSIONING & TOLERANCING PER ANSI Y14.5M-1982.
- 2. CONTROLLING DIMENSION: INCH.
- 3. DIMENSIONS ARE SHOWN IN MILLIMETERS [INCHES].
- 4. OUTLINE CONFORMS TO JEDEC OUTLINE TO-204AE.

Conforms to JEDEC Outline TO-204AE Dimensions in Millimeters and (Inches)

International

 WORLD HEADQUARTERS: 233 Kansas St., El Segundo, California 90245, Tel: (310) 322 3331

 IR GREAT BRITAIN: Hurst Green, Oxted, Surrey RH8 9BB, UK Tel: ++ 44 1883 732020

 IR CANADA: 15 Lincoln Court, Brampton, Ontario L6T3Z2, Tel: (905) 453 2200

 IR GERMANY: Saalburgstrasse 157, 61350 Bad Homburg Tel: ++ 49 6172 96590

 IR ITALY: Via Liguria 49, 10071 Borgaro, Torino Tel: ++ 39 11 451 0111

 IR FAR EAST: K&H Bldg., 2F, 30-4 Nishi-Ikebukuro 3-Chome, Toshima-Ku, Tokyo Japan 171 Tel: 81 3 3983 0086

 IR SOUTHEAST ASIA: 1 Kim Seng Promenade, Great World City West Tower, 13-11, Singapore 237994 Tel: ++ 65 838 4630

 IR TAIWAN:16 FI. Suite D. 207, Sec. 2, Tun Haw South Road, Taipei, 10673, Taiwan Tel: 886-2-2377-9936

 http://www.irf.com/
 Data and specifications subject to change without notice.

www.irf.com